MTS-2700US1 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yuji Judai : Art Unit:

Serial No.: To Be Assigned : Examiner:

Filed: Herewith :

FOR: SEMICONDUCTOR DEVICE AND :

ITS FABRICATION METHOD :

DIVISIONAL OF:

Applicant: Yuji Judai : Art Unit: 2814

Serial No.: 09/177,038 : Examiner: H. Weiss

Filed: October 22, 1998 :

FOR: SEMICONDUCTOR DEVICE :

HAVING A FERROELECTRIC :

CAPACITOR WITH TENSILE STRESS

PROPERTIES

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

SIR:

Prior to examination, please amend the above-identified application as follows:

IN THE TITLE:

Please delete the title in its entirety and substitute therefore: